

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

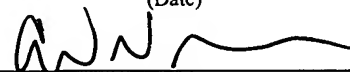
Applicant : Ritala et al.
Appl. No. : 10/618,429
Filed : July 10, 2003
For : METHOD FOR GROWING THIN
OXIDE FILMS
Examiner : Robert M. Kunemund
Group Art Unit : 1765

CERTIFICATE OF MAILING

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

January 7, 2005

(Date)



Andrew N. Merickel, Reg. No. 53,317

RESPONSE TO OFFICE ACTION**Mail Stop Amendment**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

The present paper is submitted in response to the Office Action mailed on November 17, 2004. Applicants respectfully request entry of the attached Terminal Disclaimer and consideration of the following remarks.

Remarks/Arguments begin on page 2 of this paper.